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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
SHIRAKAWA, Hiroaki et al

New York, New York
Date: June 15, 2005

Serial No.: 10/807,052

Group Art Unit: 1765

Date Filed: March 22, 2004

For: SUBSTRATE TREATING METHOD AND APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY LETTER

Sir:

We filed the above application with the U. S. Patent and Trademark Office on March 22, 2004.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,

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